



Docket No.: SON-1690
(PATENT)

21/E
Amend E w/RC
Y. Rohman
8/29/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ichiro Fujiwara

Application No.: 09/431,076

Art Unit: 2811

Filed: November 1, 1999

Examiner: H. Vu

For: NONVOLATILE SEMICONDUCTOR
MEMORY DEVICE AND PROCESS OF
PRODUCTION AND WRITE METHOD
THEREOF

**PRELIMINARY AMENDMENT FILED WITH
REQUEST FOR CONTINUED EXAMINATION**

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Preliminary Amendment also serves as a full and timely response to the final Office Action dated March 24, 2003 (Paper No. 15). Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

RECEIVED
AUG 21 2003
TECHNOLOGY CENTER 2800